



500.41316VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAJI, et al  
Serial No.: ~~10/090,750~~  
10/659,394  
Filed: September 11, 2003  
For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS  
AND PLASMA PROCESSING METHOD USING IT  
Group: 1763  
Examiner: P. Hassanzadeh

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT**

Mail Stop Non-Fee Response  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

March 22, 2004

Sir:

In response to the Notice of Non-Compliant Amendment dated March 17, 2004, applicants submit herewith a complete listing of the claims for the above-identified application.

Listing of the Claims; and

Remarks are included following the listing.